

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

| | |
|---------------------------|--|
| Title of Invention | COMPOSITION FOR AN ETCHING MASK COMPRISING A SILICON-CONTAINING MATERIAL |
|---------------------------|--|

Application Number : 10/789319



Confirmation Number: 9202

First Named Applicant: Frank Xu

Attorney Docket Number: P121-63-03

Art Unit: 1712

Examiner: Marc S. Zimmer

Search string: (6468642 or 5542978 or 5837314 or 6565776 or 6503914 or 6649272 or 6204343 or 4614667 or 3810874 or 6737489 or 6721529 or 6664306 or 6790905 or 6544594 or 6774183 or 6830819 or 6802870 or 5389696).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|---------------------|------|-------|----------|
| | 1 | 6468642 | 2002-10-22 | Bray et al. | B1 | | |
| | 2 | 5542978 | 1996-08-06 | Kindt-Larsen et al. | | | |
| | 3 | 5837314 | 1998-11-17 | Beaton et al. | | | |
| | 4 | 6565776 | 2003-05-20 | Li et al. | B1 | | |
| | 5 | 6503914 | 2003-01-07 | Benish et al. | B1 | | |
| | 6 | 6649272 | 2003-11-18 | Moore et al. | B2 | | |
| | 7 | 6204343 | 2001-03-20 | Barucha et al. | B1 | | |
| | 8 | 4614667 | 1986-09-30 | Larson et al. | | | |
| | 9 | 3810874 | 1974-05-14 | Mitsch et al. | | | |
| | 10 | 6737489 | 2004-05-18 | Linert et al. | B2 | | |
| | 11 | 6721529 | 2004-04-13 | Chen et al. | B2 | | |
| | 12 | 6664306 | 2003-12-16 | Gaddam et al. | B2 | | |
| | 13 | 6790905 | 2004-09-14 | Fitzgerald et al. | B2 | | |
| | 14 | 6544594 | 2003-04-08 | Linford et al. | B2 | | |
| | 15 | 6774183 | 2004-08-10 | Palumbo et al. | B1 | | |
| | 16 | 6830819 | 2004-12-14 | Kaplan et al. | B2 | | |
| | 17 | 6802870 | 2004-10-12 | Chang et al. | B2 | | |
| | 18 | 5389696 | 1995-02-14 | Dempsey et al. | | | |

Signature

| | |
|---------------|------|
| Examiner Name | Date |
| | |